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GP 1853\$  
PATENT  
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Aratani, et al.

Serial No.: 09/198,798

Filed: December 9, 1999

For: THIN FILM FORMATION USE  
SPUTTERING TARGET MATERIAL,  
THIN FILM FORMED USING SAME,  
AND OPTICAL RECORDING MEDIUM

Attorney Docket No.: 09792486-0100  
(formerly P99,2247)

Group Art Unit: 1853

Examiner: R. McDonald

Date: January 22, 2001

**Certificate of Mailing (37 CFR 1.8(a))**

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the:

Assistant Commissioner for Patents  
Washington, D.C. 20231, on:

Date of Deposit: January 22, 2001

1/22/01  
Date

**TRANSMITTAL LETTER**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Enclosed herewith is an Applicant's Response to the First Office Action of Katsuhisa Aratani and Takashi Veno in the above-identified patent application entitled THIN FILM FORMATION USE SPUTTERING TARGET MATERIAL, THIN FILM FORMED USING SAME, AND OPTICAL RECORDING MEDIUM.

Also enclosed are: Request for Extension of Time (1 page)  
Check # 112,814 in the amount of \$90.00 (1 page)  
Return Receipt Postcard (1 page)  
Office Action Response (4 pages)

The Commissioner is hereby authorized to charge any additional fees required, as well as any patent application processing fees associated with this communication for which full payment has not been tendered to Deposit Account No. 19-3140. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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Shashank Upadhye, Esq.  
(Certificate of Recognition Letter Attached)